

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of

Noriaki ODA

Appln. No.: 09/739,620

Confirmation No.: 4739

Filed: December 20, 2000

Group Art Unit: 2812

Examiner: Ha Nguyen

For: SEMICONDUCTOR DEVICE WITH  
COPPER-BASED WIRING LINES AND  
METHOD OF FABRICATING THE SAME

#6/Election  
9/12/01  
V. Vannal

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
Washington, D.C. 20231

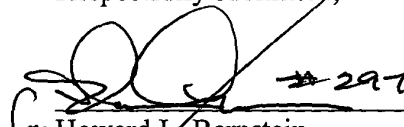
Sir:

In response to the Office Action dated August 28, 2001 in which the Examiner has required a restriction, Applicant responds by electing Group II, *i.e.*, claims 1-11, drawn to a semiconductor device. This election is made without prejudice to the filing of a divisional application directed to claims 12-14.

Prompt and favorable action on the elected claims is now respectfully requested.

Respectfully submitted,

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Date: September 7, 2001